

<b>Notice of References Cited</b>	Application/Control No. 10/666,646	Applicant(s)/Patent Under Reexamination BASAWAPATNA ET AL.	
	Examiner John R. Schnurr	Art Unit 2623	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,699,105 A	12-1997	Chen et al.	725/120
*	B	US-5,729,281 A	03-1998	Utsumi et al.	725/119
*	C	US-6,188,871 B1	02-2001	Kitamura et al.	725/120
*	D	US-2002/0019984 A1	02-2002	Rakib, Selim Shlomo	725/111
*	E	US-2002/0073431 A1	06-2002	Nikolich, Paul E.	725/111
*	F	US-6,728,965 B1	04-2004	Mao, Weidong	725/38
*	G	US-6,848,116 B1	01-2005	Land, Thomas	725/78
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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